3/8 (THU)							
Registration 9:00-							
Plasma science 6	9:30-10:00 Invited Lecture <08aB01I>	Nitride Semicondu	9:30-10:00 Invited Lecture <08aE01I>	Nano Materials 6	9:30-10:00 Invited Lecture <08aD01I>	Bio applications	
Etching <chair> H. Toyoda (Nagoya University)</chair>	Remi Dussart (University of Orléans) "Cryogenic Processes for Silicon Deep Etching, Low-K Materials and Atomic Layer Etching"	ctors 6 Optical Devices 2 <chair> D. Feezell (The University of New Mexico)</chair>	Xuelun Wang (AIST) "Directional Micro LED based on Evanescent Wave Coupling"	Surface Modification s and Tribology <chair> T. C. Wei (Chung Yuan Cristian University) H. Kosaka (Gifu University)</chair>	Ta-Chin Wei (Chung Yuan Cristian University) "Super-amphiphobic Teflon-like Fluorocarbon Nanoflakes Deposited by Microwave Plasmas"	6 <chair> K. Niitsu (Nagoya University)</chair>	Daiki Kanno "Cytotoxic Effects of Fullerenol Enhanced by Atmospheric Pressure Plasma" 9:45-10:00 1366 <08aF020> Yukihro Kurokawa "Cytotoxic Substances in the Laser Generated Plasma Activated Medium (LPAM)"
	10:00-10:15 1013 <08aB02O> Minoru Sasaki "Processing Thin-film Membrane and Dry Etching Release of Torsional Resonator for Uncooled Infrared Sensor"		10:00-10:15 1164 <08aE020> Bo-Syun Hong "Efficiency Enhancement for InGaN-based Photodetector with a Photon-recycle Porous- GaN Bragg Distributed Reflector"		10:00-10:15 1268 <08aD02O> Daisuke Ogawa "Size Dependency of Plasma-treated Carbon Nanotubes for Mechanical Enhancement of Polyurethane"		10:00-10:15 1048 <08aF030> Jun-Seok Oh "Vacuum Ultraviolet Absorption Spectroscopy for Analysis of Plasma- activated Water"
	10:15-10:30 1140 <08aB03O> Takayoshi Tsutsumi "Understanding Morphology and Chemical Bonds of Si Surface in Cyclic CF4/Ar Plasma Process by Surface Analysis without Air Exposure"		10:15-10:30 1283 <08aE03O> Gauangshuo Cai "Electrolyte-gated In203 Dual-gate Thin Film Transistor Driven by Low Voltage for Visible-blind UV Detection"		10:15-10:30 1269 <08aD030> Ranjit R. Borude "Plasma Surface Treatment of Carbon Films Deposited by Magnetron Sputtering"		10:15-10:30 1365 <08aF04O> Nevena Puac "Plasma Recycling of Water Contaminated with Organophosphates used for Seed Germination"
				-	10:30-10:45 <08aD040> Hiroyuki Kousaka "Effect of Humidity on the Friction Properties of a-C:H and a-C:H:SI Films Deposited by PECVD Employing Microwave Sheath- voltage Combination Plasma"		
Break 10:45-11:00							
Topical Session 3 Energy Nanomateri al <chair> T. Ito (Gifu University)</chair>	11:00-11:30 Invited Lecture <08aA05I> Chen-Hao Wang (National Taiwan University of Science & Technology) "Synthesis of Non-precious Metal Catalysts by Different Kinds of Cobalt Precursors for Oxygen Reduction Reaction in Alkaline Media" 11:30-12:00 Invited Lecture <08aA06I> Tomohiro Nozaki (Tokyo Institute of Technology) "Nonthermal Plasma-assisted Catalysis of Greenhouse Gas"						
	Nonthermal Plasma-assisted Catalysis of Gre						
	12:00-12:30 Invited Lecture <08aA07I> Masaharu Shiratani (Kyushu Univeristy) "IoT-oriented Solar Cells Fabricated using Plasma-based Nanotechnology"						
	12:30-13:00 Invited Lecture <08aA08I> Takeyoshi Sugaya (AIST) "Smart Stacked Heterogeneous Multijunction Solar Cells Fabricated by Advanced Bonding using Metal Nanoparticle Arrays"						
Award <chair></chair>	Award						
Closing							